## CLAIMS

- 1. A solid-state image pickup device comprising a plurality of photoelectric conversion elements and a plurality of switching elements, characterized in that the photoelectric conversion element is formed above at least one switching element, and a shielding electrode layer is disposed between the switching elements and the photoelectric conversion elements.
- A solid-state image pickup device according
   to claim 1, wherein one photoelectric conversion element and one or more switching elements are disposed in one pixel.
- 3. A solid-state image pickup device according to claim 1 or 2, wherein the photoelectric conversion element has a photoelectric conversion layer, and the photoelectric conversion layer includes an insulating layer, a semiconductor layer, and a high impurity concentrated semiconductor layer.
- 4. A solid-state image pickup device according
  to claim 1 or 2, wherein the photoelectric conversion
  element has a photoelectric conversion layer, and the
  photoelectric conversion layer includes a first high
  impurity concentrated semiconductor layer of one
  conductivity type, a semiconductor layer, and a

  25 second high impurity concentrated semiconductor layer
  of a conductivity type opposite to the one
  conductivity type of the first high impurity

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concentrated semiconductor layer.

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- 5. A solid-state image pickup device according to any one of claims 1 to 4, wherein the shielding electrode layer is not formed above a signal line connected to one of a source electrode and a drain electrode of the switching element.
- 6. A solid-state image pickup device according to any one of claims 1 to 5, wherein the shielding electrode layer is held at a constant electric potential.
- 7. A solid-state image pickup device according to claim 6, wherein the shielding electrode layer is grounded.
- 8. A solid-state image pickup device according to any one of claims 1 to 7, wherein each of the switching elements is constituted by a TFT, and the shielding electrode layer is disposed so as to cover an upper portion of a channel of each of the TFTs.
- 9. A solid-state image pickup device according
  20 to claim 8, wherein the shielding electrode layer has
  a width equal to or smaller than a channel width of
  the TFT and is disposed so as to cross a TFT driving
  wiring.
- 10. A solid-state image pickup device according
  25 to any one of claims 1 to 9, wherein the shielding electrode layer is made of a high melting point metal.
  - 11. A solid-state image pickup device according

to claim 10, wherein the shielding electrode layer is made of molybdenum (Mo), chromium (Cr), titanium (Ti), tungsten (W), or molybdenum-tungsten (MoW).

- 12. A solid-state image pickup device according to claim 1, wherein the shielding electrode layer is an electrode layer thinner than each of a gate electrode layer, a source/drain electrode layer, and a sensor biasing electrode layer.
- 13. A solid-state image pickup device according

  to claim 1, wherein the solid-state image pickup
  device includes a gate electrode layer, a gate
  insulating layer, a first amorphous semiconductor
  layer, a first n type semiconductor layer, a
  source/drain electrode layer, a first interlayer

  15 insulating layer, the shielding electrode layer, a
  second interlayer insulating layer, a sensor lower
  electrode layer, an insulating layer, a second
  amorphous semiconductor layer, a second n type
  semiconductor layer, a transparent electrode layer,
  and a sensor biasing electrode layer.
  - 14. A solid-state image pickup device according to claim 13, wherein one photoelectric conversion element and one or more TFTs are disposed in one pixel.
  - 25 15. A radiation image pickup device, characterized in that a wavelength conversion unit is disposed above the photoelectric conversion element

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in the solid-state image pickup device as claimed in any one of claims 1 to 9.

- 16. A radiation image pickup device according to claim 15, wherein one photoelectric conversion element and one or more switching elements are disposed in one pixel.
- 17. A radiation image pickup device comprising a radiation conversion layer for directly converting radiation into electric charges, and a plurality of switching elements, characterized in that the radiation conversion layer is formed above one or more switching elements, and a shielding electrode layer is disposed between the switching elements and the radiation conversion layer.
- 18. A radiation image pickup device according to claim 17, wherein the radiation image pickup device includes a gate electrode layer, a gate insulating layer, a first amorphous semiconductor layer, a first n type semiconductor layer, a source/drain electrode layer, a first interlayer insulating layer, the shielding electrode layer, a second interlayer insulating layer, a sensor lower electrode layer, a radiation conversion layer, and a sensor biasing electrode layer.

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